

ASMMC.036AUS



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : SOPHIE ET AL.
App. No. : 09/975,466
Filed : October 9, 2001
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Examiner : Kielin, E.

Group Art Unit 2813

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May 19, 2003
(Date)

Andrew N. Merickel, Reg. No. 53,317

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AMENDMENT AND REQUEST FOR RECONSIDERATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present amendment is in response to the Final Office Action mailed on March 28, 2003, setting a three month term for response. As the present amendments are believed to place the application in condition for allowance, their entry is respectfully requested.